

<b>Notice of References Cited</b>	Application/Control No. 10/659,299	Applicant(s)/Patent Under Reexamination HASHIMOTO ET AL.	
	Examiner Julie Anne Watko	Art Unit 2627	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Fukuzawa et al, "Specular spin-valve films with an FeCo nano-oxide layer by ion-assisted oxidation", 15 May 2002, J. Ap. Phys. v. 91 no. 10 p. 6684).
	V	
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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